



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 1, 2026	
IGI Report Number	LG825640445
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ANTIQUE CUSHION CUT
Measurements	9.03 X 6.64 X 4.19 MM

GRADING RESULTS

Carat Weight	2.05 CARATS
Color Grade	E
Clarity Grade	VVS 1

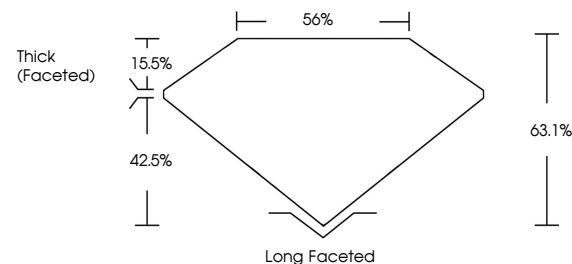
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG825640445

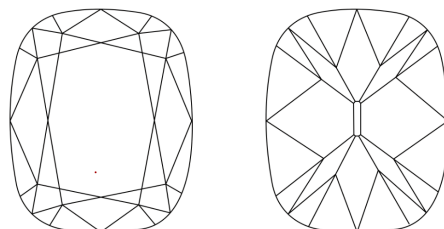
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG825640445
Report verification at igi.org

PROPORTIONS

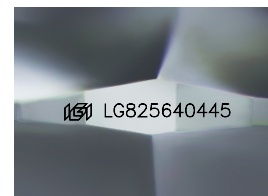


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



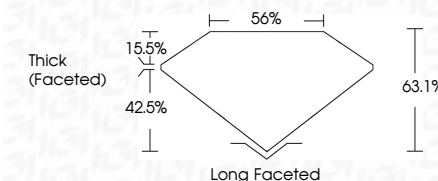
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www.igi.org



September 1, 2026	GI Report No. LG2554046	2105 CARATS	E	VVS 1	Long Faceted
NIQUE CUSHION CUT				63.1%	EXCELLENT
				65%	EXCELLENT
				Thick (Faceted)	NONE
					18K LG2554046

Comments: This is a Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA